



00862.0022167

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shinichi HARA et al.) : Examiner: D. Ben Esplin
Application No.: 09/818,625) : Group Art Unit: 2851
Filed: March 28, 2001) :
For: EXPOSURE APPARATUS, GAS REPLACEMENT) June 20, 2003
METHOD, SEMICONDUCTOR DEVICE :
MANUFACTURING METHOD, SEMICONDUCTOR) :
MANUFACTURING FACTORY, AND EXPOSURE :
APPARATUS MAINTENANCE METHOD)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWINGS

Sir:

Transmitted herewith are two (2) formal drawing sheets, Figures 3 and 13, to be substituted for the corresponding drawing sheets currently on file in the above-identified application.

Figures 3 and 13 incorporate the changes requested by Applicants in a Request for Approval of Drawing Changes filed on February 28, 2003, which were subsequently approved by the Examiner in the Office Action dated March 21, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicants

Steven E. Warner

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